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DANAMRAJ & YOUST, P.C.

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P. 10

Attorney Docket No.: 1384-1023

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application: John L. Pierce

Serial No.: 09/738,193

Filed: December 15, 2000

Art Unit: 2827

Examiner: David E. Graybill

For: System, Method and Apparatus for Constructing  
a Semiconductor Wafer-Interposer Using B-  
Stage Laminates

Commissioner of Patents  
Washington, D.C. 20231

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Change of Correspondence Address

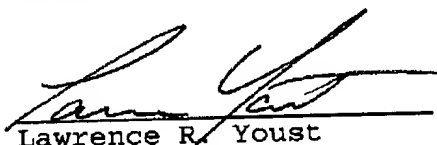
Dear Sir:

Regarding the above-referenced patent application, please  
direct all further correspondence to attorney of record at the  
following new address:

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Dated this 7th day of October, 2002.

Respectfully submitted:



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